

INFORMATION DISCLOSURE
CITATION

Affy. Docket No.

2476-30

Applicant

COOPER et al.

Filing Date

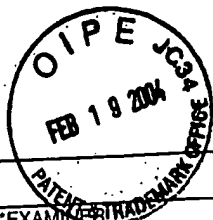
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10/63,092

Group



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EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
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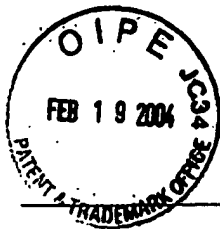
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Date Considered

5/3/04

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FOREIGN PATENT DOCUMENTS

[illegible]

OTHER DOCUMENTS (including Author, Title, Date, Pertinent pages, etc.)

27	Yu and Cardona, <i>Fundamentals of Semiconductors: Physics and Material Properties</i> (1999) at page 196
↑	Tutorial at http://plc.cwru.edu/tutorial/enhanced/files/lcd/tn/tn.htm .
	IBM Technical Disclosure Bulletin, Vol. 34 No. 10A, "Ultra-Resolution Image Transfer," (March 1992)
	Paufler et al., "High-throughput optical direct write lithography," <i>Solid State Technology</i> , pp. 175, 176, 178, 180, 182 (June 1997)
	Kuwamura et al., "Analysis of Operating Mechanism in Semiconductor Optical Modulator with Electron-Depleting Adsorption Control," <i>Electronics and Communications in Japan</i> , Pt. 2, Vol. 79, No. 5, pp. 616-625 (1996)
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	Yamada et al., "A Semiconductor Optical Switch Utilizing Optical Absorption in Depletion Layer," <i>CLEO</i> 1991, page 158
↓	Kuwamura, et al., "Panel-Type Semiconductor Optical Modulator Using Electron Depleting Absorption Control," <i>Jpn. J. Appl. Phys.</i> Vol. 32 (1993), pp. 578-582, Part 1, No. 1B (January 1993)
27	Binet et al., "Electric field effects on excitons in gallium nitride," <i>PHYSICAL REVIEW B</i> , Vol. 54, Number 11 (9/15/1996).

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